

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/737,271	LO ET AL.	
Examiner	Art Unit	
Ellen Kim	2874	

	SEARCHED				
Class	Subclass	Date	Examiner		
385	94	12/7/2005	EK		
398	139	12/7/2005	EK		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
East	12/7/2005	5 EK	